

Part I

How to separate good crystals from bad ones based on longitudinal non-uniformity profiles?

requirement for crystal non-uniformity

- 1 Mass resolution of $H \rightarrow \gamma\gamma$ for E_γ from 25 GeV to 500 GeV

$$\left(\frac{\sigma}{E}\right)^2 = \left(\frac{a}{\sqrt{E}}\right)^2 + \left(\frac{\sigma_n}{E}\right)^2 + (c)^2$$

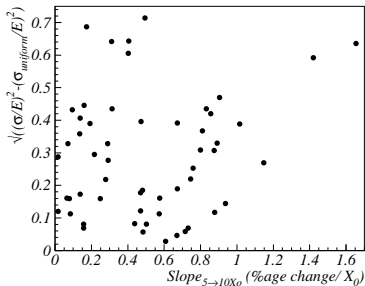
non-uniformity contributes to the constant term and must be **less than 0.3%** (from ECAL TDR)

- 2 CMS note 96/002 describes GEANT studies of non-uniformity. Uniformity profile should have slope **less than 0.3% per X_0** in $5X_0$ to $10X_0$ range

Question: Are items 1 and 2 the same thing?

cms note 96/002

Figure: This is a plot from CMS Note 96/002. Each point represents GEANT estimated contribution to M_H width vs FNUF slope for a crystal. A sample of 63 crystals is shown



Answer: No!

- ▶ many crystals with slope $\leq 0.3\%/X_0$ have $\sigma \geq 0.3\%$
- ▶ many crystals with $\sigma \leq 0.3\%$ have slope $\geq 0.3\%/X_0$

GEANT EM showers in PWO

Figure: Sketch of setup geometry for GEANT

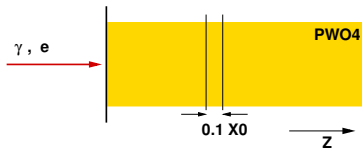
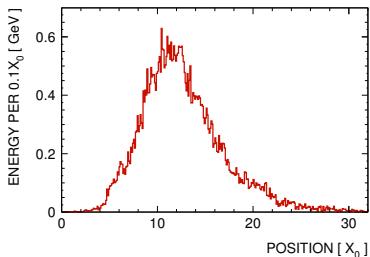


Figure: Profile of deposited energy for one shower from γ with $E = 50 \text{ GeV}$



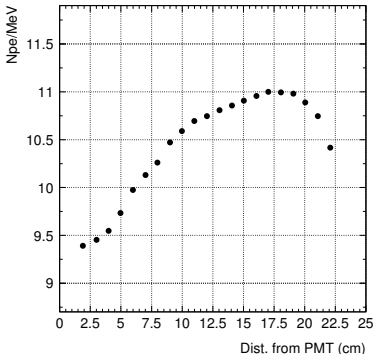
Repeat studies described in CMS Note 96/002 (with some modifications) to get some understanding

Steps:

- ▶ A particle hits a wall of PWO4, $32X_0$ thick. Transverse dimensions - not a factor.
- ▶ Record a shower: deposited ΔE_i in steps $\Delta z = 0.1X_0$ as a function of z_i .
- ▶ Make a library of 1000 showers for γ and e^- with incident $E = 10, 20, 50, 120,$ and 250 GeV

Test one particular crystal with GEANT showers.

Figure: Longitudinal light yield function for a crystal presented on ECAL DPG meeting in Oct 7, 2005 by R.Paramatti.



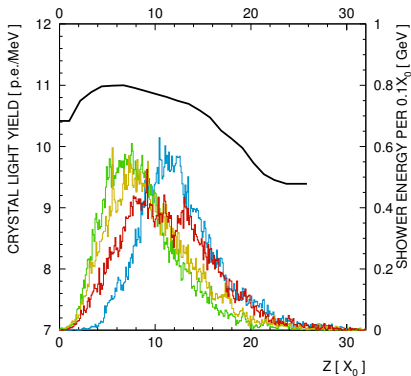
LY function is measured in 21 points, 1 cm apart. Too coarse for these studies.

Use simple interpolation:

- ▶ Linear interpolation between measurements
- ▶ At the end points, assume constant LY constant to the edges of the crystal.
- ▶ Convert horizontal scale to X_0 units, assuming $X_0 = 0.89 \text{ cm}$
- ▶ Simple linear interpolation can be replaced by polynomial fit

Resolution due to non-uniformity

Figure: Light yield function in X_0 units for a crystal (black) and several shower profiles for γ with 50 GeV energy.



Steps to determine contribution of longitudinal non-uniformity to energy resolution:

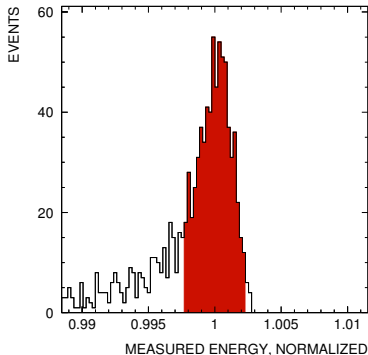
- 1 Energy of a shower i measured by a crystal, normalized

$$R_i = \frac{\int_0^L E_i(z) \cdot LY(z) dz}{\int_0^L E_i(z) dz}$$

For $LY(z) = const$, every shower will have the same R_i . Statistical fluctuations in energy deposited by a particle is taken out by normalization. Fluctuations in R_i are pure non-linearity effect.

Resolution due to non-uniformity (cont'd)

Figure: Distribution of measured energy for photons with $E = 120 \text{ GeV}$, normalized to most probable value (black histogram). 68% of events are in region shaded with red color.



- 2 Obtain a distribution of R_i , ($i = 1, \dots, 1000$) for γ or e^- with the same incident energy
- 3 Find shortest interval, $[R_{min}, R_{max}]$, that contains 68.3% of measurements
- 4 Most probable R

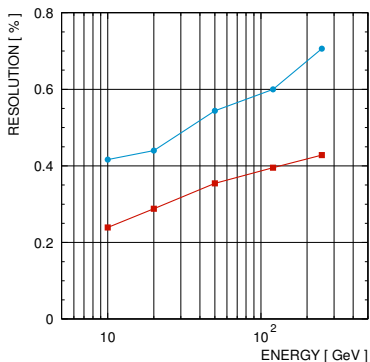
$$R_{peak} = \frac{R_{max} + R_{min}}{2}$$

- 5 Resolution due to non-uniformity

$$\Delta_{LNU} = \frac{1}{2} \frac{R_{max} - R_{min}}{R_{peak}}$$

Resolution vs Energy

Figure: Δ_{LNU} vs energy of a particle for γ (blue) and e^- (red)

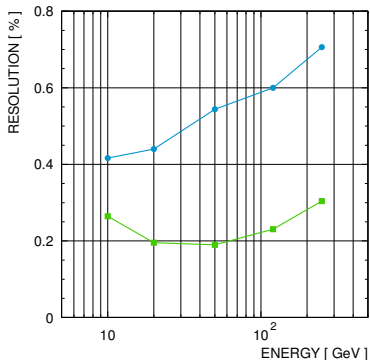


- ▶ Δ_{LNU} is energy dependent. One can use E_γ spectrum from $H \rightarrow \gamma\gamma$ to determine average non-uniformity contribution of this crystal to M_H width.
- ▶ Effects of non-linearity from this crystal have different magnitude for γ and e^- .

This crystal has $FNUF = 0.31\%$ per X_0 which is **considered almost good enough** to provide less than 0.3% to M_H resolution due to non-uniformity. But it contributes $\sim 0.5\%$ to M_H width.

Effects of preshower detector

Figure: Δ_{LNU} vs γ energy for the crystal with (green) and without (blue) preshower detector in front of it



Preshower detector in front of endcap ECAL has $3X_0$ total. $2.5X_0$ of it comes from lead converters. To estimate preshower effects, energy of a shower i measured by a crystal, normalized

$$R_i = \frac{\int_0^L E_i(z - 3X_0) \cdot LY(z) dz}{\int_0^L E_i(z - 3X_0) dz}$$

This crystal's contribution to M_H width is $\sim 0.2\%$ if there is a preshower detector in front of it.

So, what about this crystal?

- 1 This crystal will contribute $\sim 0.5\%$ to M_H resolution if it is in the barrel (no preshower). So, this crystal is “bad”.
- 2 This crystal will contribute $\sim 0.2\%$ to M_H resolution if it is in endcap, behind the preshower detector. So, this crystal is “good”.
- 3 This crystal has $FNUF = 0.31\%$ per X_0 . In this case, $FNUF$ value does not help us to make a fair judgement about this crystal.

Status. Summary. Next steps

- ▶ Need to introduce $E(\gamma)$ from $H \rightarrow \gamma\gamma$. It will allow to calculate one number per crystal: an average contribution to M_H resolution
- ▶ Get a sample of non-uniformity profiles for ~ 100 crystals and compare GEANT approach vs FNUF slope values.

Suspicion: Two approaches of crystal evaluation give different results:

- ▶ with GEANT shower libraries
 - ▶ with a simple slope in $5X_0 - 10X_0$ range
-
- ▶ The “slope” approach is based on conclusions from “GEANT” approach.

Why not to use the GEANT showers in a first place? It is as simple and quick as the linear fit.

Part II

Is it possible to measure longitudinal non-uniformity profile of a crystal with required accuracy using conventional PMT (not an HPMT)?

Simulations of longitudinal LY scans

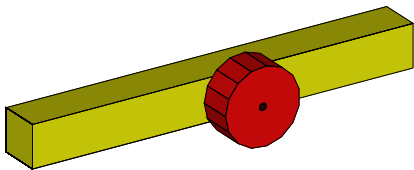
Objectives

1. Understanding of PWO response to Co-60 photons
2. Optimizing PMT running conditions wrt scan accuracy
3. Identifying best fit function for ADC spectrum
4. Understanding accuracy of the fit and optimization of the fit
5. Optimization of collimator for Co-60
6. Other

This is ongoing study.

GEANT setup

Figure: sketch of GEANT geometry: PWO crystal (yello) and Co-60 source assembly (red).



- ▶ PWO4 crystal:
 - ▶ $2.5 \times 2.5 \times 23.0 \text{ cm}^3$
 - ▶ Density is 8.30 g/cm^3
 - ▶ $X_0 = 0.841 \text{ cm}$ (GEANT)
CMS crystals $X_0 = 0.89 \text{ cm}$
- ▶ Source assembly:
 - ▶ Co-60 source
 - ▶ Collimator
- ▶ Cutoff energy for photons and electrons in PWO is set to minimum (10 keV)
- ▶ Output deposited $E(x, y, z)$ to next step in these simulations.

Source assembly

Figure: sketch of source geometry: Co-60 source (yellow); Collimator (blue) and PWO crystal (red).

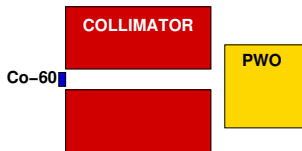
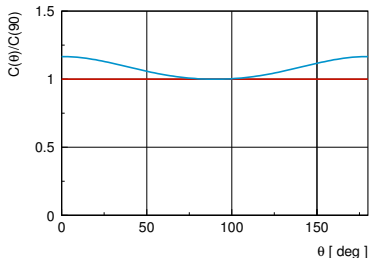


Figure: Correlation in angle between photons: isotropic (red) and Co-60 (blue)



- ▶ Source is 3 mm in diameter and emits 2 photons:

- ▶ $E_1 = 1.173 \text{ MeV}$
- ▶ $E_2 = 1.333 \text{ MeV}$.
- ▶ same origin
- ▶ anisotropical distribution

$$C(\theta) = C_0 \left(1 + \frac{\cos^2\theta}{8} + \frac{\cos^4\theta}{24} \right)$$

- ▶ Collimator - TUBE geometry

- ▶ Outer diameter: 4.4 cm
- ▶ Inner diameter: 0.4 cm
- ▶ Length: 2 cm.
- ▶ Material: ???
- ▶ Collimator-crystal gap is 2 mm

No collimator right now, $L=0$

Cross Sections for γ and e^- Interactions with PWO

Co-60 γ in PWO: compton scattering (photo electrons rarely); electron loose all energy immediately via ionization but sometime produce brems γ . Low energy γ are absorbed in PWO. Some γ escape PWO

Figure: Photon cross section in PWO vs energy

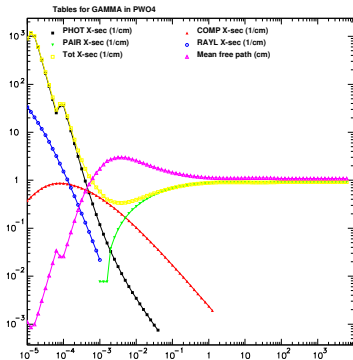
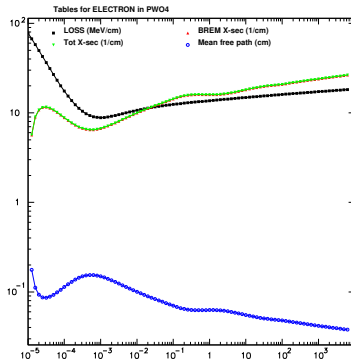
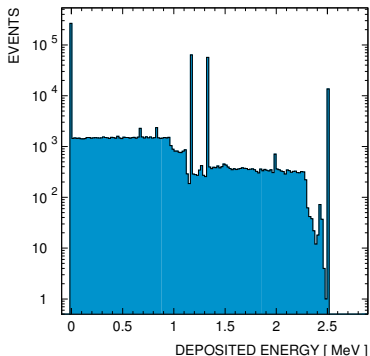


Figure: Electron cross section in PWO vs energy



Energy Deposition in PWO per Co-60 Disintegration

Figure: Energy deposited by Co-60 disintegration in PWO crystal (GEANT)



Visible energy in PWO ($E > 0$):

1.173 MeV 28.06%

1.133 MeV 24.54%

2.306 MeV 6.89%

continuum 40.51%

This composition should go into ADC fit function. The effects of uncertainty in cross sections and geometry have to be studied.

This spectrum is GEANT simulated when the source has no collimator and positioned 2 mm away from the side of the crystal.

Average number of photo-electrons per event

$$n_{pe} = \int_V P(x, y, z) \frac{E(x, y, z)}{\epsilon_0} dv$$

$E(x, y, z)dv$ energy deposited in volume dv at (x, y, z)

ϵ_0 average deposited energy to make one scintillator photon

$P(x, y, z)$ probability for scint. photon emitted from (x, y, z) to produce a photo-electron in the PMT cathode (integrated over several variable: direction, energy etc.)

$$P(x, y, z) = C_0 \cdot F_{nuf}(x, y, z)$$

C_0 some constant

$F_{nuf}(x, y, z)$ Non-uniformity function, = 1 for perfectly uniform crystal

$$\frac{1}{V} \int_V F_{nuf}(x, y, z) dv = 1$$

Average number of photo-electrons per event (cont'd)

$$n_{pe} = \frac{C_0}{\epsilon_0} \int_V F_{nuf}(x, y, z) E(x, y, z) dv$$

For perfectly uniform crystal, $F_{nuf}(x, y, z) = 1$,

$$n_{pe} = \frac{C_0}{\epsilon_0} \int_V E(x, y, z) dv = \frac{C_0}{\epsilon_0} E_{tot}$$

$$\frac{C_0}{\epsilon_0} = \frac{n_{pe}}{E_{tot}} = LY_0$$

LY_0 Light Yield of the crystal

$$n_{pe} = LY_0 \int_V F_{nuf}(x, y, z) E(x, y, z) dv$$

To generate n_{pe} , use $E(x, y, z)$ from GEANT, adjust with introduced non-linearity function F_{nuf} , and multiply by measured LY_0 for the crystal.

Simulation of ADC spectrum

Actual number of photo-electrons is random generated,

$$P(N) = \frac{n_{pe}^N}{N!} e^{-n_{pe}}$$

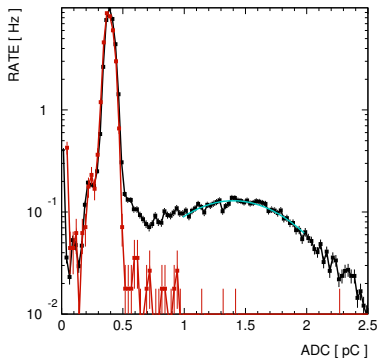
ADC channel is random generated according to Gaussian with mean and sigma

$$m_N = N \cdot m_{1pe} + m_{PED}$$
$$\sigma_N^2 = N \cdot \sigma_{1pe}^2 + \sigma_{PED}^2$$

where m_{1pe} and σ_{1pe} are Gaussian parameters of single photo-electron ADC spectrum; m_{PED} and σ_{PED} are Gaussian parameters for pedestal.

Measuring m_{1pe} and σ_{1pe} .

Figure: ADC spectrum of blue LED at HV=1800 V (black dots). Noise ADC is also shown (red dots)



- ▶ Blue LED shines through PWO crystal
- ▶ LED is driven with a pulser
- ▶ LED pulse duration is ~ 50 nsec
- ▶ ADC gate is 100 nsec
- ▶ LED pulser amplitude is adjusted to get $\sim 20\%$ efficiency for LED (single photo-electron mode)
- ▶ DAQ trigger is LED pulser output
- ▶ Noise spectrum is taken with LED unplugged
- ▶ Tip of the 1 p.e. peak is fitted with Gaussian

m_{1pe} and σ_{1pe} vs PMT voltage

Figure: Measured position of 1 p.e. peak vs PMT voltage

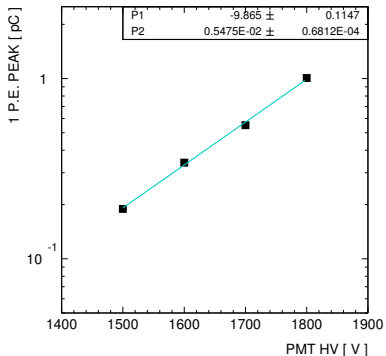
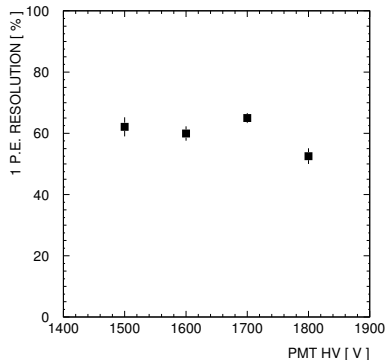


Figure: Measured resolution of 1 p.e. peak vs PMT voltage



Steps to generate ADC spectrum

1. Generate map of deposited energies, $E(x, y, z)$, and apply non-uniformity function, $F_{nuf}(x, y, z)$, using GEANT
2. Random number of photo-electrons, N , according to Poisson with average rate of $LY \cdot E$, where LY is light yield (input parameter) and E is random number according to distribution from Step 1.
3. ADC is a random number according to Gaussian distribution with mean of

$$N \cdot m_{1pe} + m_{PED}$$

and width

$$\sigma^2 = N \cdot \sigma_{1pe}^2 + \sigma_{PED}^2$$

where m_{1pe} and m_{PED} are positions of 1 photo-electron and pedestal peaks respectively; σ_{1pe} and σ_{PED} are widths of one photo-electron and pedestal distributions respectively (all four are input parameters)

DATA vs MC. Co-60 rate in PWO at HV=1800 V

- ▶ Our source had 379.1 kHz rate of disintegrations on Oct 1, 2005 (according to its certificate)
- ▶ Nov 20, 2005: Our source has rate 369.0 kHz
- ▶ According to MC simulations, 43.6% of disintegrations leave at least 1 p.e. signal in PMT. Therefore, the predicted rate is 160.9 kHz.
- ▶ On Nov 20, I measured rate of 174 kHz with estimated background rate of 5.2 kHz.
- ▶ DATA=168.8 kHz vs MC=160.9 kHz

MC predicts rate of CO-60 signals in PWO crystal to better than 5% accuracy. Reminder: GEANT predicts $X_0 = 0.84 \text{ cm}$ and CMS quotes $X_0 = 0.89 \text{ cm}$

ADC fit function

$$F(x) = \int_{E>0} dE \left(\sum_{N=1}^{\infty} \frac{A}{\sigma\sqrt{2\pi}} \exp \left[-\frac{(x-m)^2}{2\sigma^2} \right] \frac{\mu^N}{N!} e^{-\mu} \right)$$

$$m = N \cdot m_{1pe} + m_{ped}$$

$$\sigma^2 = N \cdot \sigma_{1pe}^2 + \sigma_{ped}^2$$

$$\mu = g(E) \cdot LY$$

x ADC channel in pC

A Amplitude

m_{1pe} position of a photo-electron peak in pC

σ_{1pe} resolution of a photo-electron peak in pC

m_{ped} position of a pedestal peak in pC

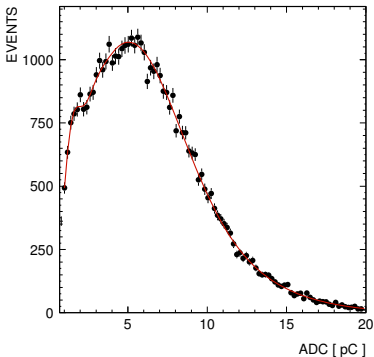
σ_{ped} resolution of a pedestal peak in pC

LY light yield in photo-electrons

$g(E)$ spectrum of energy deposition by Co-60 photons in a **uniform** crystal as calculated in GEANT simulations

fit is working

Figure: MC generated ADC spectrum of Co-60 source (black dots) and its fit (red)



ADC was generated with

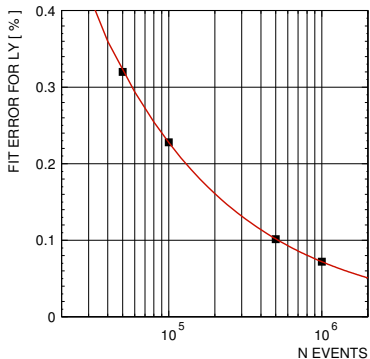
- ▶ $LY = 5.00 p.e.$
- ▶ $m_{1pe} = 1.0 pC$
- ▶ $\sigma_{1pe} = 0.55 pC$
- ▶ $m_{ped} = 0.395 pC$
- ▶ $\sigma_{ped} = 0.0335 pC$
- ▶ 50,000 events were generated

ADC was fitted with LY and A floating. Other parameters were fixed to its true values. MINUIT returned:

- ▶ $LY = 5.0033 \pm 0.0160 p.e.$
- ▶ $\chi^2 = 91.07$ based on 95 points.

fit errors vs number of events

Figure: Fit error on LY parameter vs number of events in ADC spectrum (black dots). A general $\sim 1/\sqrt{N}$ function is also shown (red line)



Two-parameter fit: LY and amplitude.
Errors on LY are MINUIT errors.
They follow general dependence:

$$\Delta = \frac{C_0}{\sqrt{N}}$$

fit sensitivity vs light yield

Fit errors depend on shape of ADC spectrum. This dependence is small and it can be compensated with total number of events in a spectrum.

Co-60 ADC spectra are generated for crystals with total LY in 1 – 20 $p.e.$ range. Each spectrum is fitted with two floating parameters: LY and amplitude. Each spectrum has the same 1) number of events and 2) fitted range of ADC

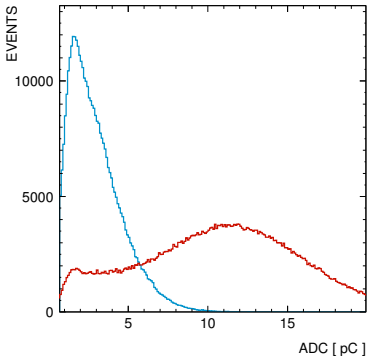


Figure: Co-60 ADC spectra for two crystals: a dim crystal with $LY = 2 p.e.$ (blue) and a bright crystal with $LY = 10 p.e.$ (red)

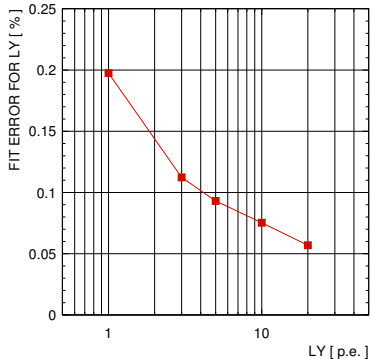


Figure: Fit sensitivity for LY parameter vs LY if ADC spectra has 500K events

fit errors vs number of parameters

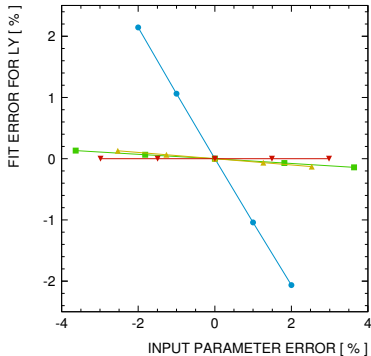
Errors on fit parameters as calculated by MINUIT.

	fit #1	fit #2	fit #3	fit #4	fit #5
LY	.072%	.56%	.092%	.56%	.074%
m_{1pe}	FIXED	.52%	FIXED	.54%	FIXED
σ_{1pe}	FIXED	.71%	FIXED	FIXED	.64%
m_{ped}	FIXED	FIXED	1.04%	FIXED	FIXED
σ_{ped}	FIXED	FIXED	> 100%	FIXED	FIXED

It seems important to know the position of 1 p.e. peak for precision measurement of light yield

LY bias due to input parameter uncertainty

Figure: Bias in fit result for *LY* if one of the input parameters is fixed to wrong value: mean value for 1 p.e. peak (blue), width of 1 p.e. peak (green), mean value for pedestal peak (yellow), width of pedestal peak (red)



So far, fit had two floating parameters (light yield and amplitude) and other four parameters were fixed to its **true** values. What happens if one of the four parameters is fixed to the wrong value?

Position of 1 p.e. peak is **a single most important** input parameter for the fit. Fluctuations in position of 1 p.e. peak result in *LY* fluctuations of the same magnitude.

What are the implications for our experimental setup?

Two scenarios

1 Mean value of 1 p.e. peak fluctuates during LY non-uniformity scan significantly (more than 0.5%)

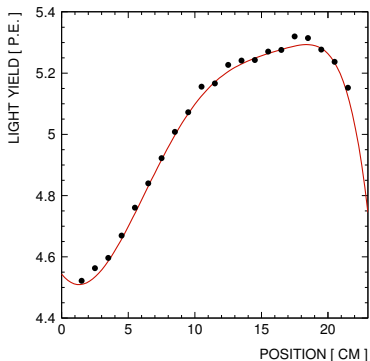
Need to determine the average position of 1 p.e. peak during each measurement with $< 0.1\%$ accuracy. Take Co-60 and LED triggers at the same time. Need to simulate effects of fluctuations on fit and non-uniformity measurements. (ToDo)

2 Mean value of 1 p.e. peak is stable during LY non-uniformity scan (fluctuations are less than 0.1%).

Use the same value of 1 p.e. peak position in a fit function for all ADC spectra. The discrepancy between true value of this parameter and value used in the fit function will result in LY error of the same magnitude. What are the effects on non-uniformity measurements?

Simulation and Measurement on Non-uniformity

Figure: Crystal non-uniformity function used during GEANT simulations (red line) and fit results for LY (black dots)



1. Use an arbitrary non-uniformity curve in GEANT simulations.
2. Simulate ADC spectrum using point-like beam of photons from Co-60 (ideal collimator)
3. Fit ADC spectrum and find LY
4. Repeat 2 and 3 for 21 positions of Co-60 along the crystal

Measurements are not exactly on the line due to finite bin size of $g(E)$ distribution used in simulations (easy to improve, ToDo)

Bias in non-uniformity vs error in 1 p.e. peak

In the second scenario, it is possible to measure non-uniformity accurately even if we make an error in 1 p.e. peak position of few %. Realistic error is $< 1\%$.

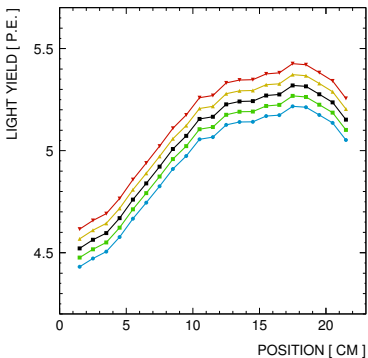


Figure: Measured non-uniformity profile using different values for position of 1 p.e. peak: nominal is 1.00 p.e (black), 1.02 p.e. (red), 1.01 p.e.(yellow), 0.99 p.e. (green), and 0.98 p.e. (blue)

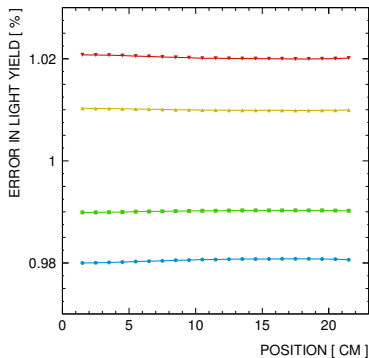


Figure: Ratio of nonuniformity profiles: measured with error over correct one. The error is in input position of 1 p.e. peak: 2% (red), 1% (yellow), -1% (green), -2% (red)

Status. Summary. Next steps

- ▶ Theoretically, it is possible to make precision measurement of LY with conventional PMT
- ▶ Position of 1 p.e. peak should be stable within 0.1%. Is it possible?
 - ▶ PMT
 - ▶ HV power supply
 - ▶ Temperature
- ▶ Make simultaneous measurements of 1 p.e. peak with LED
- ▶ Need to simulate fluctuations of 1 p.e. peak and its implications
- ▶ There is a long list of GEANT studies to optimize the experimental setup, running conditions and fitting procedure